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Rosemarie Contella

Name

Signature

August 20, 2003 Date of Signature

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Takeuchi et al.

Serial No.

10/037,133

Filed

December 27, 2001

For

Silver Vanadium Oxide Having

Low Internal Resistance And

Method Of Manufacture

Examiner

Unknown

Art Unit

1745

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 CFR 1.56

Assistant Commissioner for Patents Alexandria, VA 22313-1450

Applicants submit herewith patents, publications or other 1. information of which they are aware, which they believe may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR 1.56.

The filing of this Information Disclosure Statement (IDS) shall not be construed as a representation that a search has been made (37 CFR 1.56(g)), an admission that the information

cited is, or is considered to be, material to patentability or A that no other material information exists.

The filing of this IDS shall not be construed as an admission against interest in any manner (Notice of Jan. 9, 1992, 1135 O.G. 13-25, at 25).

- 2. Attached is Form PTO-1449. Legible copies of all items listed accompany this IDS.
- 3. No item of information contained in this IDS was cited in a communication from a foreign patent office in a counterpart foreign application, or to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in § 1.56(c) more than three months prior to the filing of the statement.
- 4. The person making this statement is the agent who signs below, who makes this statement on the information supplied by the inventors and the information in the agent's file.

Respectfully submitted,

Bv

Michael F. Scalise Reg. No. 34,920

WILSON GREATBATCH TECHNOLOGIES, INC. 10,000 Wehrle Drive Clarence, New York 14031 (716) 759-5810 August 20, 2003

U.S. PATENT DOCUMENTS							
Examiner Initials*	Cite No. 1	U.S. Pate	nt Document Kind Code 2 (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines O Where Relevant Passages or Relevant Figures Appear	
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Examiner Initials*	Cite No. 1	Fo Offic	reign Patent Document Kind Code5  e3 Number4 (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	Т6
	1	EP	0 478 303 A2	Medtronic, Inc.	04-01-1992		X
	2	EP	0 638 946 A2	Wilson Greatbatch Ltd.	02-15-1994		х
	3	EP	0 849 225 A1	Medtronic, Inc.	06-24-1998		Х
	4	EP	1 058 326 A2	Wilson Greatbatch Ltd.	12-06-2000		х
	5	EP	0 856 490 A1	Medtronic, Inc.	08-05-1998		х

Examiner	Date	
Signature	Considered	

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Unique citation designation number. 2 See attached Kinds of U.S. Patent Documents. 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.